

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED
DEPOSITION (IBAD)

App. No.: 10/602,467 Filed: June 23, 2003

Examiner: Brian K. Talbot Group Art Unit: 1762

Customer No.: 34456 Confirmation No.: 2664

Atty. Dkt. No.: 1014-SP103

MS AF

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Final Office Action mailed June 30, 2008, please amend the above-identified application as follows:

The Claim Amendments begin on page 2.

The Remarks being on page 8.